

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Number : 10/584,301 Confirmation No.: 9824  
: National Stage of Int'l Application No. PCT/DK03/000934  
Applicants : Henrik JENSEN, *et al.*  
§371 Date : August 7, 2007  
Title : METHOD AND APPARATUS FOR PRODUCTION OF A  
COMPOUND HAVING SUBMICRON PARTICLE SIZE  
AND A COMPOUND PRODUCED BY THE METHOD  
TC/Art Unit : 1615  
Examiner: : Steven J. Bos  
  
Docket No. : 55320.000402  
Customer No. : 21967

**MAIL STOP MISSING PARTS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REQUEST FOR CORRECTED FILING RECEIPT**

Sir:

Applicants respectfully request that a Corrected Filing Receipt be issued in the above-captioned patent application. An error should be corrected in "Title" as follows:


Please delete "Method For Production of a Product Having Sub-Micron Primary Particle Size, Product Produced by the Method and Apparatus For Use of The Method" and insert -- METHOD AND APPARATUS FOR PRODUCTION OF A COMPOUND HAVING SUBMICRON PARTICLE SIZE AND A COMPOUND PRODUCED BY THE METHOD -- as the correct title.

A copy of the Official Filing Receipt mailed 08/24/2007, with the correction marked in red is attached for your convenience.

Applicants believe that no fees are due. However, in the event of any variance between the fees determined by Applicants and those determined by the U.S. Patent and Trademark Office, please charge any such variance to Deposit Account No. 05-1135.

Respectfully submitted,  
HUNTON & WILLIAMS LLP

Date: October 4, 2007

By:   
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UNITED STATES PATENT AND TRADEMARK OFFICE

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APPLICATION NUMBER	FILING or 371(c) DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	TOT CLAIMS	IND CLAIMS
10/584,301	08/07/2007	1615	1330	55320.000402	26	3

CONFIRMATION NO. 9824

21967  
HUNTON & WILLIAMS LLP  
INTELLECTUAL PROPERTY DEPARTMENT  
1900 K STREET, N.W.  
SUITE 1200  
WASHINGTON, DC 20006-1109

FILING RECEIPT

Date Mailed: 08/24/2007

Receipt is acknowledged of this non-provisional patent application. The application will be taken up for examination in due course. Applicant will be notified as to the results of the examination. Any correspondence concerning the application must include the following identification information: the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections**

**Applicant(s)**

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**Power of Attorney:** The patent practitioners associated with Customer Number 21967

**Domestic Priority data as claimed by applicant**

This application is a 371 of PCT/DK03/00934 12/23/2003

**Foreign Applications**

**If Required, Foreign Filing License Granted:** 08/21/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/584,301**

**Projected Publication Date:** 11/29/2007

**Non-Publication Request:** No

**Early Publication Request:** No

**Title**

~~Method For Production of a Product Having Sub-Micron Primary Particle Size, Product  
Produced by the Method and Apparatus For Use of The Method~~

Preliminary Class

-- METHOD AND APPARATUS FOR PRODUCTION OF A  
424 COMPOUND HAVING SUBMICRON PARTICLE SIZE

## PROTECTING YOUR INVENTION OUTSIDE THE UNITED STATES

AND A COMPOUND PRODUCED BY THE METHOD --

Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filing of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process **simplifies** the filing of patent applications on the same invention in member countries, but **does not result** in a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

Almost every country has its own patent law, and a person desiring a patent in a particular country must make an application for patent in that country in accordance with its particular laws. Since the laws of many countries differ in various respects from the patent law of the United States, applicants are advised to seek guidance from specific foreign countries to ensure that patent rights are not lost prematurely.

Applicants also are advised that in the case of inventions made in the United States, the Director of the USPTO must issue a license before applicants can apply for a patent in a foreign country. The filing of a U.S. patent application serves as a request for a foreign filing license. The application's filing receipt contains further information and guidance as to the status of applicant's license for foreign filing.

Applicants may wish to consult the USPTO booklet, "General Information Concerning Patents" (specifically, the section entitled "Treaties and Foreign Patents") for more information on timeframes and deadlines for filing foreign patent applications. The guide is available either by contacting the USPTO Contact Center at 800-786-9199, or it can be viewed on the USPTO website at <http://www.uspto.gov/web/offices/pac/doc/general/index.html>.

For information on preventing theft of your intellectual property (patents, trademarks and copyrights), you may wish to consult the U.S. Government website, <http://www.stopfakes.gov>. Part of a Department of Commerce initiative, this website includes self-help "toolkits" giving innovators guidance on how to protect intellectual property in specific countries such as China, Korea and Mexico. For questions regarding patent enforcement issues, applicants may call the U.S. Government hotline at 1-866-999-HALT (1-866-999-4158).

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Title 37, Code of Federal Regulations, 5.11 & 5.15

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